

IFW

<b>TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT</b> (Under 37 CFR 1.97(b) or 1.97(c))					Docket No. <b>16748</b>	
In Re Application Of: <b>Yukio Morishige, et al.</b>						
Application No. <b>10/600,075</b>		Filing Date <b>June 20, 2003</b>		Examiner <b>Richard R. Bueker</b>	Customer No. <b>23389</b>	Group Art Unit <b>1763</b>
Confirmation No. <b>9161</b>						
Title: <b>LASER CVD DEVICE AND LASER CVD METHOD</b>						
<p>Address to: <b>Commissioner for Patents</b> <b>P.O. Box 1450</b> <b>Alexandria, VA 22313-1450</b></p> <p><b>37 CFR 1.97(b)</b></p> <p>1. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.</p> <p style="text-align: center;"><b>37 CFR 1.97(c)</b></p> <p>2. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:</p> <p style="margin-left: 40px;"><input checked="" type="checkbox"/> the statement specified in 37 CFR 1.97(e);</p> <p style="text-align: center;"><b>OR</b></p> <p style="margin-left: 40px;"><input type="checkbox"/> the fee set forth in 37 CFR 1.17(p).</p>						

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT**  
(Under 37 CFR 1.87(b) or 1.97(c))

Docket No.  
16748

In Re Application of: Yukio Morishige, et al.

Application No. 10/600,075	Filing Date June 20, 2003	Examiner Richard R. Bueker	Customer No. 23389	Group Art Unit 1763	Confirmation No. 9161
-------------------------------	------------------------------	-------------------------------	-----------------------	------------------------	--------------------------

Title: LASER CVD DEVICE AND LASER CVD METHOD

**Payment of Fee**

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of \_\_\_\_\_ is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. 19-1013/SSMP as described below.
- ☐ Charge the amount of \_\_\_\_\_
- ☒ Credit any overpayment.
- ☒ Charge any additional fee required.
- ☐ Payment by credit card. Form PTO-2038 is attached.

**WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.**

**Certificate of Transmission by Facsimile\***

I certify that this document and authorization to charge deposit account is being facsimile transmitted to the United States Patent and Trademark Office (Fa

\_\_\_\_\_  
(Date)

\_\_\_\_\_  
Signature

\_\_\_\_\_  
Typed or Printed Name of Person Signing Certificate

**\*This certificate may only be used if paying by deposit account.**

  
Signature

**Certificate of Mailing by First Class Mail**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on

January 17, 2006

\_\_\_\_\_  
(Date)

  
Signature of Person Mailing Correspondence

Richard J. Danyko

\_\_\_\_\_  
Typed or Printed Name of Person Mailing Certificate

Dated: January 17, 2006

Richard J. Danyko  
Registration No. 33,672  
SCULLY, SCOTT, MURPHY & PRESSER  
400 Garden City Plaza, Suite 300  
Garden City, New York 11530  
(516) 742-4343

RJD/ej

cc:

<b>TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT</b> (Under 37 CFR 1.97(b) or 1.97(c))					Docket No. <b>16748</b>	
In Re Application Of: <b>Yukio Morishige, et al.</b>						
Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.	
10/600,075	June 20, 2003	Richard R. Bueker	23389	1763	9161	
Title: <b>LASER CVD DEVICE AND LASER CVD METHOD</b>						
Address to: <b>Commissioner for Patents</b> <b>P.O. Box 1450</b> <b>Alexandria, VA 22313-1450</b>						
<b>37 CFR 1.97(b)</b>						
1. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.						
<b>37 CFR 1.97(c)</b>						
2. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:						
<div style="margin-left: 40px;"> <input checked="" type="checkbox"/> the statement specified in 37 CFR 1.97(e);         </div>						
<b>OR</b>						
<div style="margin-left: 40px;"> <input type="checkbox"/> the fee set forth in 37 CFR 1.17(p).         </div>						



**UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicants:** Yukio Morishige, et al.                      **Examiner:** Richard R. Bueker  
**Serial No.:** 10/600,075                                      **Art Unit:** 1763  
**Filed:** June 20, 2003                                      **Docket:** 16748  
**For:** **LASER CVD DEVICE AND**                      **Dated:** January 17, 2006  
**LASER CVD METHOD**                                      **Confirmation No.** 9161

Mailstop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

In accordance with 37 C.F.R §§1.97 and 1.98, it is requested that the following references, which are also listed on the attached Form PTO-1449, be made of record in the above-identified case.

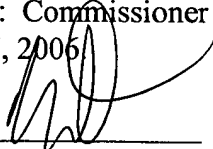
1. Japanese Laid-Open Patent Publication No. 2000-109979, dated April, 18, 2000 together with an English-language abstract;
2. U.S. Patent No. 5,182,231, dated January 26, 1993, issued to Hongo, et al.;

---

**CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 on January 17, 2006.

Dated: January 17, 2006

  
Richard J. Danyko

3. U.S. Patent No. 4,381,453, dated April 26, 1983, issued to Cuomo, et al.; and
4. U.S. Patent No. 4,801,352, dated January 31, 1989, issued to Piwczyk.

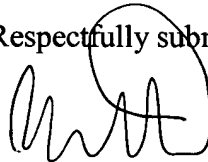
The references were cited in an Official Action dated October 14, 2005, received from the Chinese Patent Office. Applicants are submitting copies of Reference No. 1, together with a translation of the Official Action. The relevance of the references is described in the Official Action.

In compliance with the requirements of 37 C.F.R. §1.98(a)(3), as a concise statement of relevance, as it is presently understood by the individual designated in 37 C.F.R. §1.56(c) most knowledgeable about the content of the information, the undersigned attorney of record submits a translation of the Official Action in which the references were cited. The relevance to the pending U.S. patent application is that the references were cited in a foreign patent application on the same subject matter.

However, no independent analysis of the references, the accuracy of the statement of the foreign examiner or the claims of the foreign application under the laws of that country or the United States relative to the subject matter claimed in the present application has been made; the present understanding of the contents thereof by the undersigned being based on the translation of the Official Action submitted herewith.

As this Information Disclosure Statement is being submitted within three months of the issuance of an office action issued by a foreign patent office, and all references made of record herein were cited in that office action, no statement or fee is required pursuant to 37 C.F.R. §1.97(e).

Respectfully submitted,

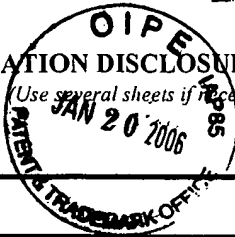
A handwritten signature in black ink, appearing to be 'RJD', enclosed within a circular scribble.

Richard J. Danyko  
Registration No. 33,672

Scully, Scott, Murphy & Presser  
400 Garden City Plaza  
Garden City, New York 11530  
(516) 742-4343

RJD/ej  
Enclosures

# INFORMATION DISCLOSURE CITATION



(Use several sheets if necessary)

Docket Number (Optional) <b>16748</b>	Application Number <b>10/600,075</b>
Applicant(s) <b>Yukio Morishige, et al.</b>	
Filing Date <b>June 20, 2003</b>	Group Art Unit <b>1763</b>

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		5,182,231	1/26/93	Hongo, et al.			
		4,381,453	4/26/83	Cuomo, et al.			
		4,801,352	1/31/89	Bernhard Piwczyk			

## U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		2000-109979	4/18/00	Japan				

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		Patent Abstracts of Japan for JP 2000-109979

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.